

Germanium Internal Charge Amplification (GeICA) for MeV-Scale Dark Matter Searches

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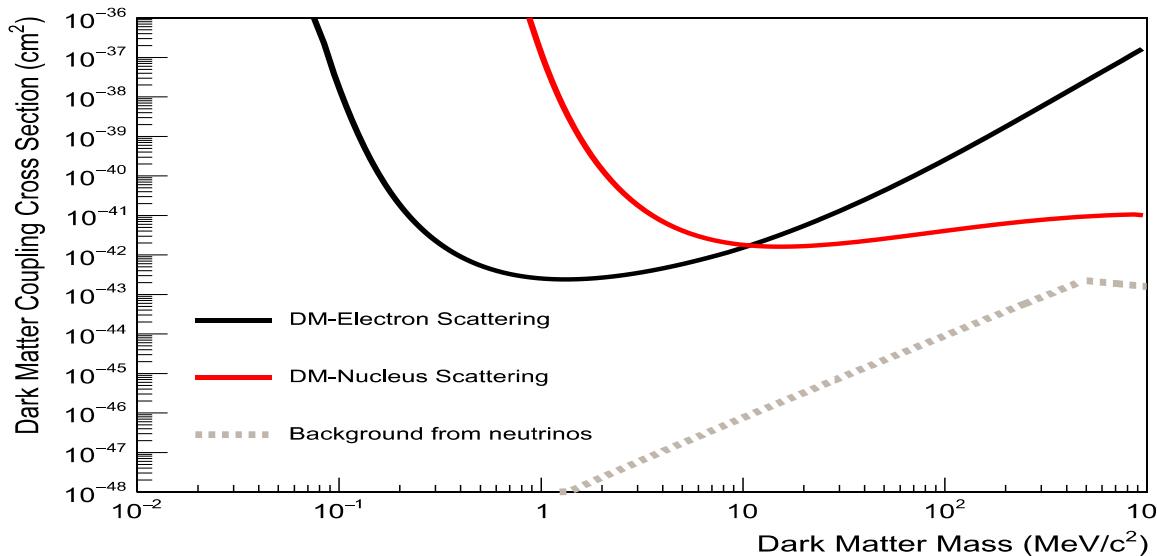
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Direct detection of MeV-scale dark matter utilizing germanium internal amplification for the charge created by the ionization of impurities has been published in THE EUROPEAN PHYSICAL JOURNAL C, Eur. Phys. J. C (2018) 78:187.

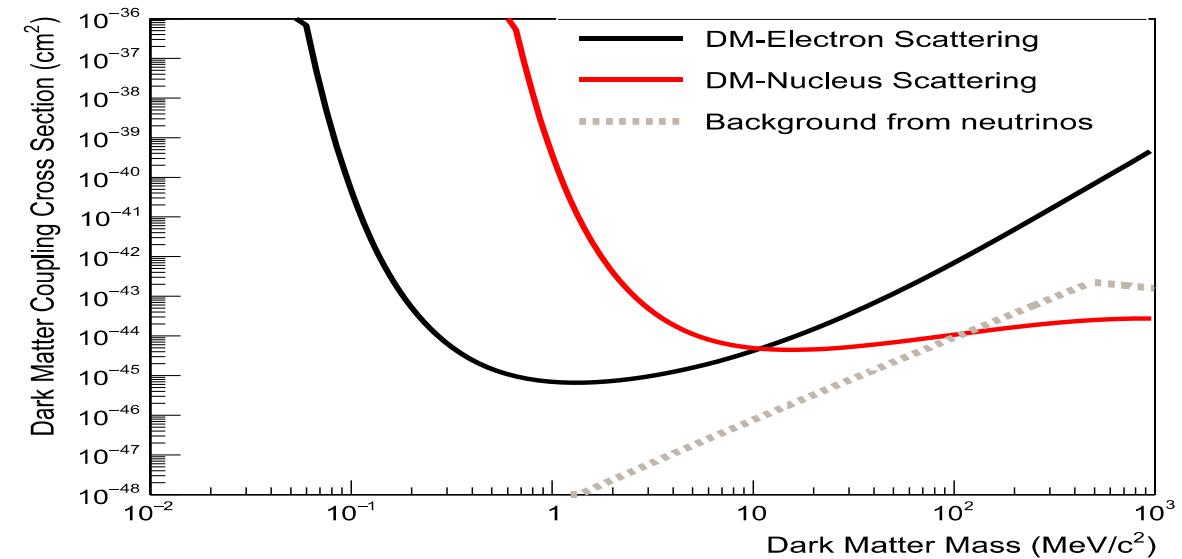
Advantages:

- Extremely low-energy threshold: ~ 0.1 eV or better
- Large in detector mass: ~ 1 kg of germanium crystal
- Very high sensitivity



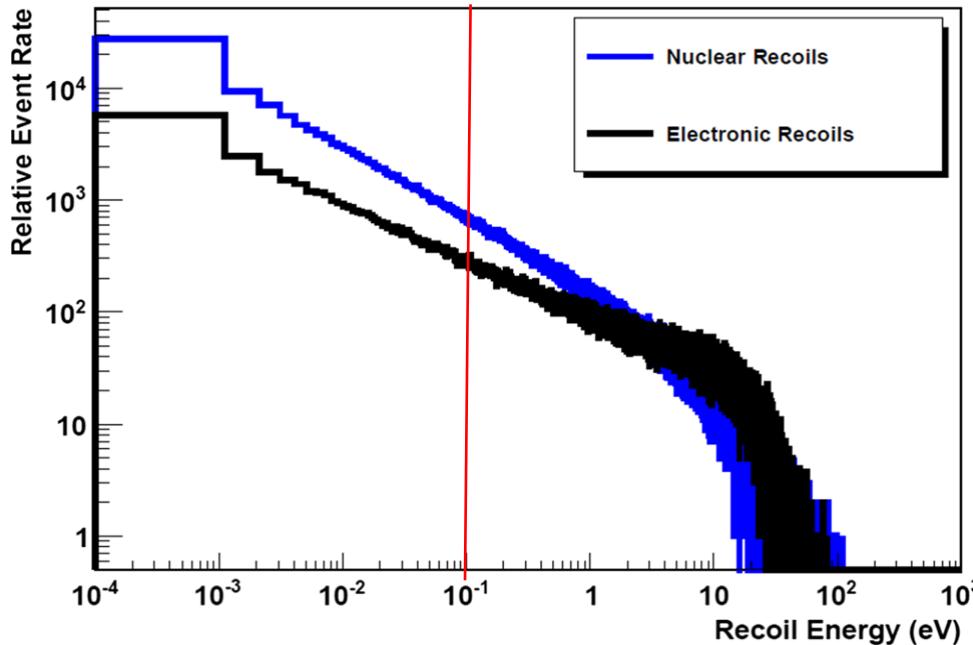
Disadvantages:

- New technology
- Not commercially available
- Intensive R&D



Left: The projected experimental sensitivity for a day. Right: The projected sensitivity for a year. The calculation was based on a GelCA detector with a mass of 1 kg.

MeV-Scale DM Induced Recoil Energy



Low-energy threshold is required



Impurity	Boron	Aluminum	Gallium	Phosphorus
Ionization energy (eV)	0.0104	0.0102	0.0108	0.012

Single
e-h pair

Internal Amplification
Through High E-field

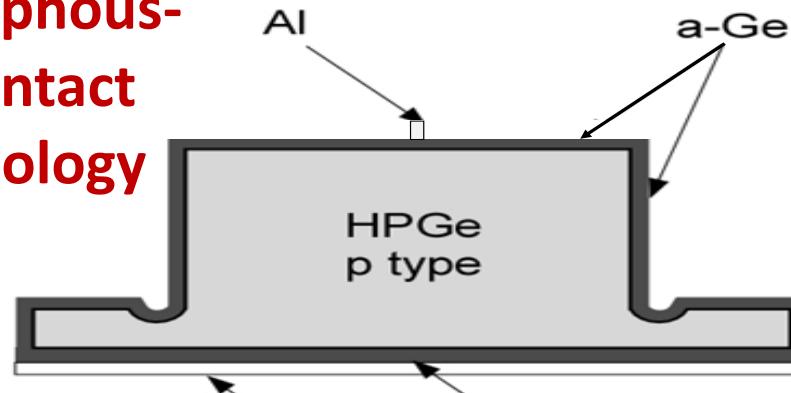
~1000
e-h pairs

Challenges:
Avalanche breakdown
Electrical breakdown

R&D in progress to demonstrate the critical technology in the lab

Six detectors were made

Amorphous-
Ge contact
technology



Injection Current and Energy Barrier Height

Shottky Theory:

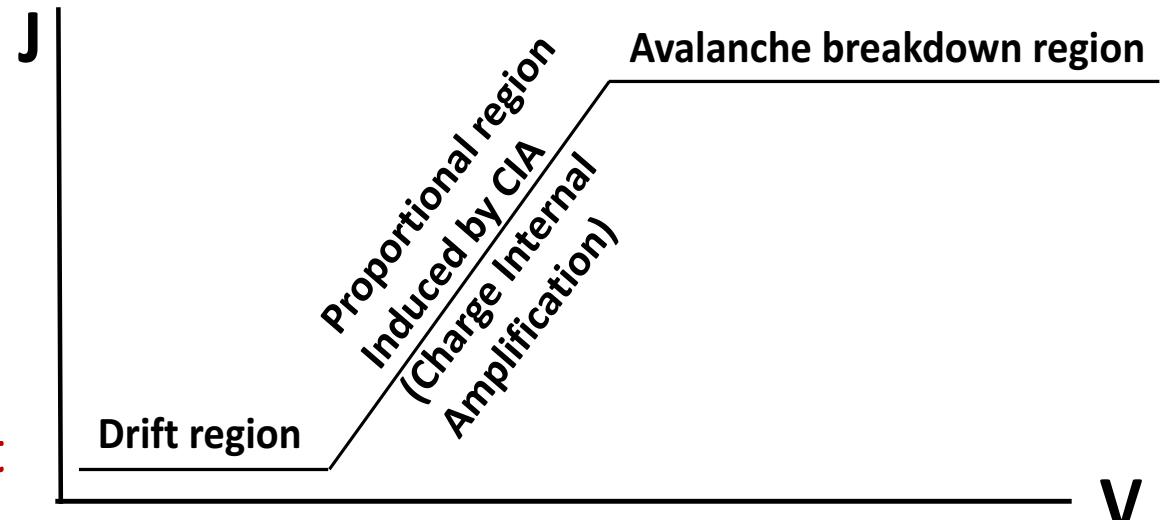
$$J = J_0 T^2 \exp\left(-\left\{\varphi - \left[\left(\frac{\epsilon_0 \epsilon_{Ge}}{N_F}\right)^{1/2} \times \frac{V + V_{depl}}{d}\right]\right\} / k_B T\right)$$

Wei et al. [arXiv: 1809.04111] from USD found that

$$J_0 = 2.45 \times 10^{-5} \text{ A/cm}^2/\text{K}^2, \varphi = 0.18 \text{ eV}, N_F = 1.6 \times 10^{18} \text{ eV}^{-1} \text{ cm}^{-3}$$

Leakage current at 4K is expected to be zero

What we have observed in the lab



$$M = \frac{1}{1 - \left(\frac{V}{V_{bk}}\right)^n}$$

M: Amplification Factor

V: Applied bias voltage

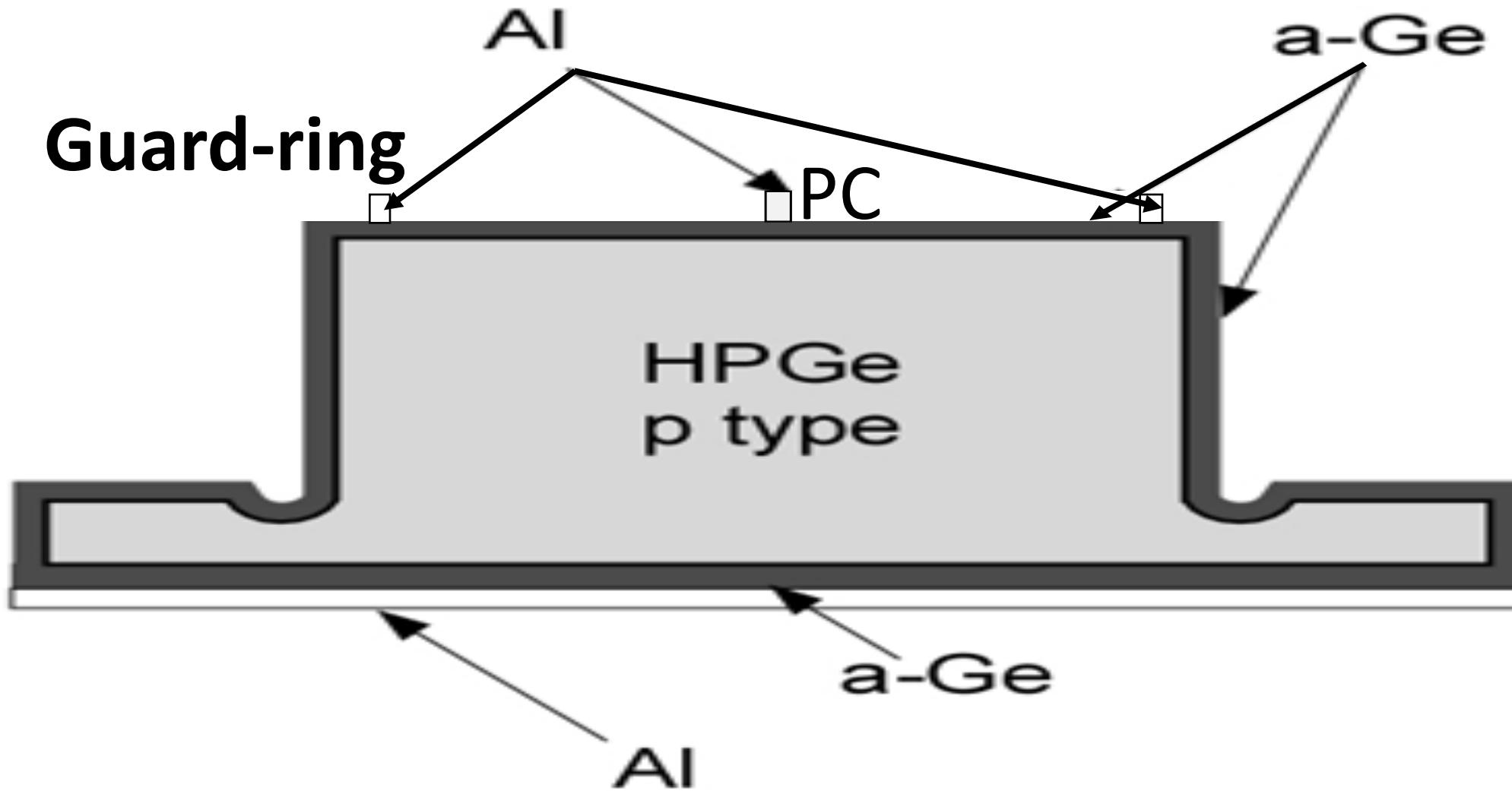
V_{bk} : Breakdown voltage

$V_{bk} = 3000$ voltage for a point contact of $\sim 1 \text{ mm}^2$

$V = 2300 - 2700, M \approx 1000$

Average ionization length: $\sim 0.9 \mu\text{m}$

Methods



Injection Current and Energy Barrier Height

Dohler and Brodsky Theory:

$$J = J_{\infty} \exp\left(-\left\{\varphi - \left[\left(\frac{\varepsilon_0 \varepsilon_{Ge}}{N_F}\right)^{1/2} \times \frac{V + V_{depl}}{d}\right]\right\} / k_B T\right)$$

Hull et al. (NIMA 538 (2005) 651 found that:

$J_{\infty} = 6.4 \times 10^6 \text{ A/cm}^2$, where $N_F = 1 \times 10^{18} \text{ eV}^{-1} \text{ cm}^{-3}$, $\varphi = 0.30 \text{ eV}$

If one requires: $\varphi = \left[\left(\frac{\varepsilon_0 \varepsilon_{Ge}}{N_F}\right)^{1/2} \times \frac{V + V_{depl}}{d}\right]$, no energy barrier height anymore

V>100,000 volts

Injection Current and Energy Barrier Height

Shottky Theory:

$$J = J_0 T^2 \exp\left(-\left\{\varphi - \left[\left(\frac{\epsilon_0 \epsilon_{Ge}}{N_F}\right)^{1/2} \times \frac{V + V_{depl}}{d}\right]\right\}/k_B T\right)$$

Wei et al. found that (USD):

$$J_0 = 2.45 \times 10^{-5} \text{ A/cm}^2/\text{K}^2, \varphi = 0.18 \text{ eV}, N_F = 1.6 \times 10^{18} / \text{eV}^{-1} \text{ cm}^{-3}$$

If one requires: $\varphi = \left[\left(\frac{\epsilon_0 \epsilon_{Ge}}{N_F}\right)^{1/2} \times \frac{V + V_{depl}}{d}\right]$, no energy barrier height anymore

V>60,000 volts

What is the value of the barrier lowering term?

$$\left[\left(\frac{\epsilon_0 \epsilon_{Ge}}{N_F} \right)^{1/2} \times \frac{V + V_{depl}}{d} \right] = 0.011 \text{ eV for } V = 3000 \text{ volts}$$

Hull: $J = 2.3 \text{ pA/cm}^2$ Wei: 2.4 pA/cm^2

If $N_F = 1 \times 10^{17} \text{ eV}^{-1} \text{ cm}^{-3}$

$$\left[\left(\frac{\epsilon_0 \epsilon_{Ge}}{N_F} \right)^{1/2} \times \frac{V + V_{depl}}{d} \right] = 0.033 \text{ eV for } V = 3000 \text{ volts}$$

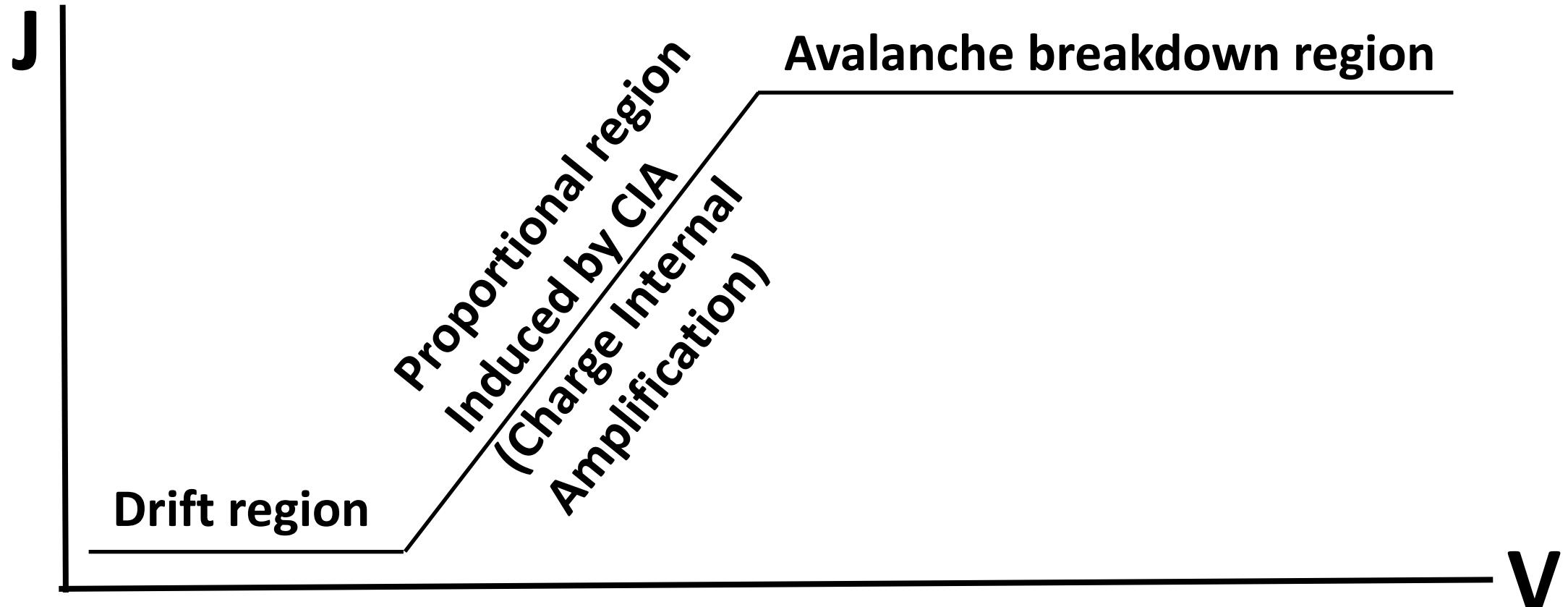
Hull: $J = 59 \text{ pA/cm}^2$ Wei: 64 pA/cm^2

What we have observed with USD-W02?

1. Point Contact: Effective area $\sim 1.5 \text{ mm}^2$
 - Injection current from $\sim 5\text{nA}$ to 100 nA in a range of applied voltage between 2300 V to 2700 V
 - Injection current of 650 nA when the applied voltage is 3000 Volts
 - Second day, Injection current was around $600 - 900 \text{ nA}$ when $V = 1600 \text{ volts}$
2. Pogo-pin: Effective area $<<1.0 \text{ mm}^2$
 - Injection current around 650 nA when $V = 1000 \text{ volts}$

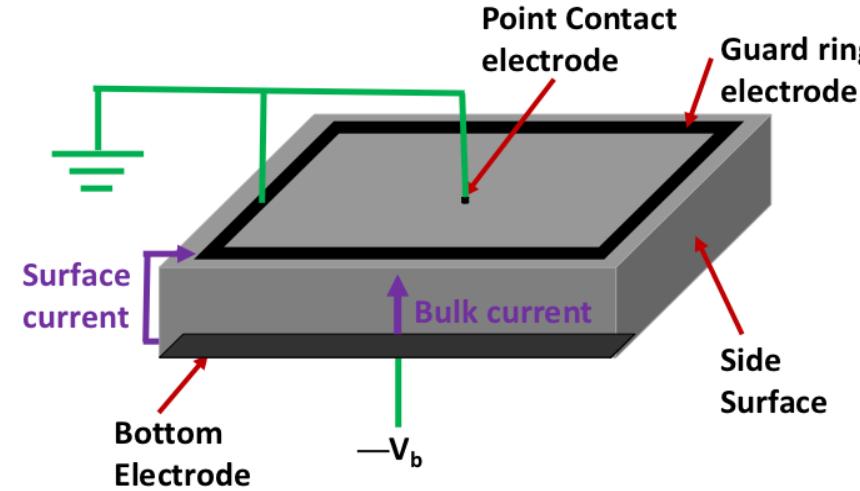
What caused the injection current to be high?

Avalanche Effect causes the injection current to be amplified

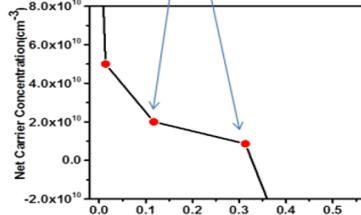
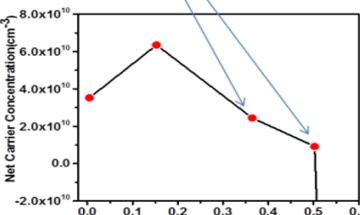
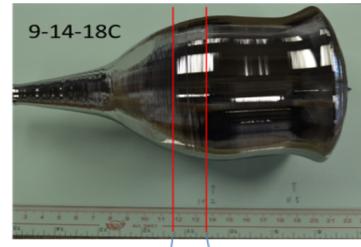
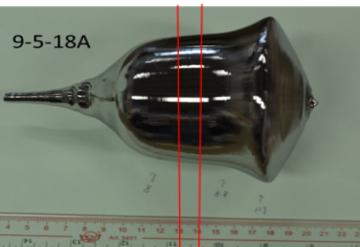


R&D for Achieving a Suitable Electrical Breakdown Prevention Structure

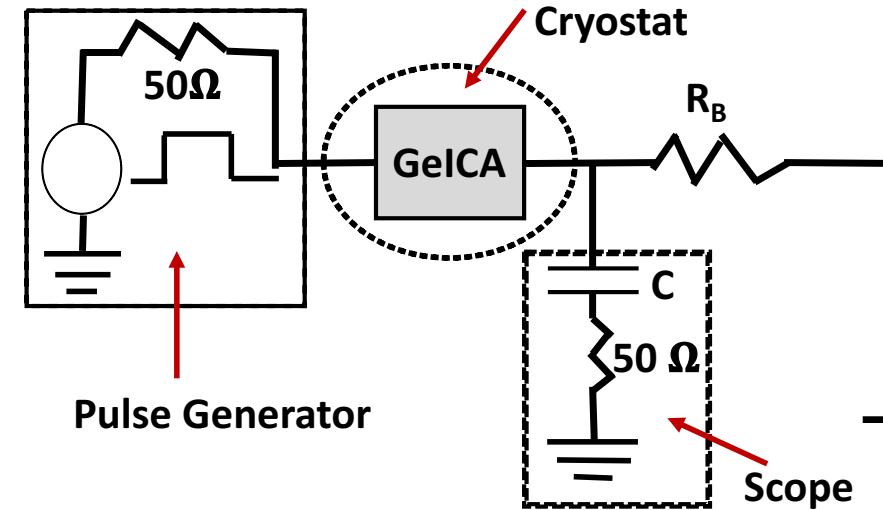
Detector design



Crystals are grown



Electronics for calibration

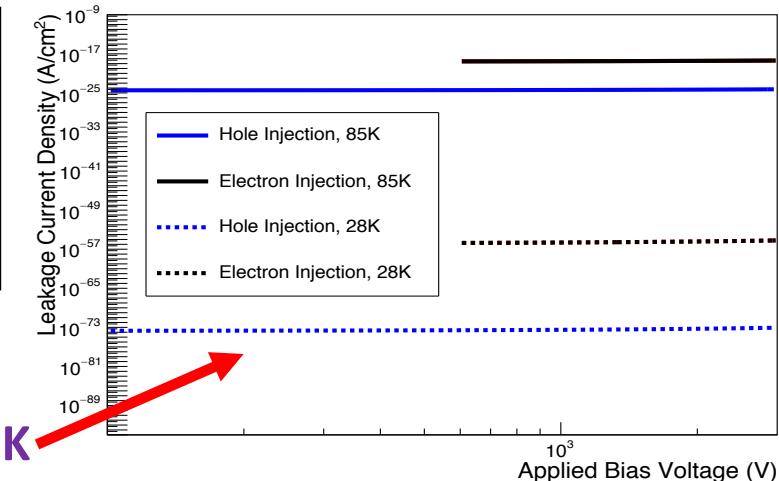


Crystal	9-5-18A	9-14-18C
Diameter (cm)	8.7	$8.6 \sim 10.5$
Thickness (cm)	1.1	2.1
Weight (g)	350	900
Impurity Concentration (cm^{-3})	$9.1 \times 10^9 \sim 2.6 \times 10^{10}$	$6.3 \times 10^9 \sim 2 \times 10^{10}$

Impurity levels are appropriate
Projected leakage current down to 28K

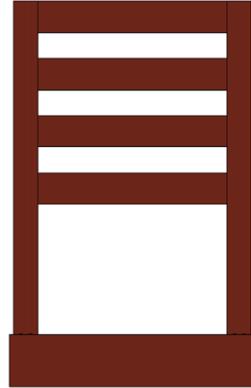
R&D needs in 3 years:

- (1) Leakage current test down to $\sim 4\text{K}$
- (2) Fabrication of detectors with 300 grams
- (3) Optimization of detector performance
- (4) Cryostat design and test
- (5) Single e-h pair calibration

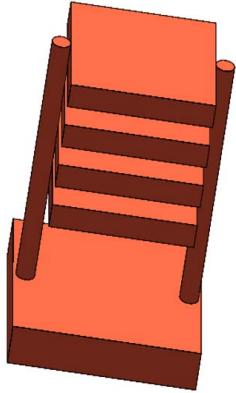


Monte Carlo simulation of the experiment

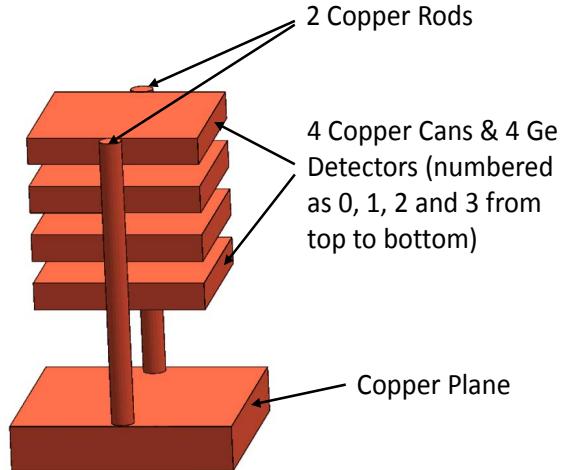
Experimental geometry for 4 detectors with a total mass of 1.2 kg



Cross-section view



Front view



Side view

Backgrounds from radioactivity in the region of interest (0.1 eV to 200 eV) is ~ 0.01 events/kg/year

Ultra low-noise electronics from LBNL

1. Low noise, low-threshold
2. Optimize for down to 0.1 pF detectors
3. Minimize cabling
4. Reduce external components
5. 27 eV-FWHM, <4 e-rms achieved

Phase-Approached Method: 1) GeCIA-0: on-going MC and Fabrication of small detectors (~ 20 grams) to observe charge internal amplification; 2) GeCIA-1: R&D to build four detector (~ 1.2 kg) at SURF in six years; 3) GeCIA-2: Build an experiment with 10 kg detectors at SURF